

Electronic Patent Application Fee Transmittal				
Application Number:		10519724		
Filing Date:		28-Dec-2004		
Title of Invention:		Device and method for the production of chlorotriflouride and system for etching semiconductor substrates using said device		
First Named Inventor/Applicant Name:		Franz Laermer		
Filer:		Gerard A. Messina/Kevin Kambo		
Attorney Docket Number:		10191/3980		
Filed as Large Entity				
U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Submission- Information Disclosure Stmt	1806	1	180	180
Total in USD (\$)				180